



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4091**  
Kazuto HIROKAWA et al. : Docket No. 2003\_0961A  
Serial No. 10/617,794 : Group Art Unit 3723  
Filed July 14, 2003 : Examiner Eileen P. Morgan

SUBSTRATE POLISHING APPARATUS

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

In response to the Restriction Requirement of March 24, 2005, please amend the above-identified application as follows: